

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. HIROI, et al
Serial No.: 10/062,666
Filed: February 5, 2002
For: PATTERN INSPECTION METHOD AND
SYSTEM THEREFOR
Group: 2881
Examiner: J. Berman
Conf. No.: 4688

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 2, 2009

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the office action dated September 9, 2008. The amendments submitted are as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.